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<b>SERIAL NUMBER</b> 10/500,975	<b>FILING OR 371(c) DATE</b> 07/08/2004 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2811	<b>ATTORNEY DOCKET NO.</b> 50389-052
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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP03/08777 07/10/2003 *A.O.A.*

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2002-202837 11/07/2002  
 JAPAN 2002-292533 10/04/2002  
 JAPAN 2002-321351 11/05/2002  
 JAPAN 2003-90727 03/28/2003  
 JAPAN 2003-148029 05/26/2003

*A.O.A.*

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

\*\* 03/15/2005

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 28	<b>TOTAL CLAIMS</b> 68	<b>INDEPENDENT CLAIMS</b> 4
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>am d.a.</i> Examiner's Signature Initials				

**ADDRESS**

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**TITLE**

Porous semiconductor and method for manufacturing same

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